

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
 Hiromichi Ohta, et al.) Before the Examiner
 Application Serial No:) Jennifer C. McNeil
 09/615,883) Group Art Unit 1775
 Filed July 14, 2000)
 TITLE: LOW-RESISTANCE ITO)
 THIN FILM AND METHOD FOR) October 18, 2002
 MANUFACTURING SUCH A FILM)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231 on:

October 18, 2002
 (Date of Deposit)

Charles P. Schmal
 Name of Registered Representative

Signature

October 18, 2002
 Date of Signature

AMENDMENT

Commissioner for Patents
 Washington, D.C. 20231

Sir:

In response to the Office Action dated May 20, 2002 please enter the following amendments and consider the accompanying remarks. Filed concurrent with this Amendment is a Request for a two-month Extension of Time to respond this Office Action and a Supplemental Information Disclosure Statement. Additionally, please charge any fees that may be due to Deposit Account No. 23-3030, but do not include any payment of issue fees that are or may become due.

IN THE CLAIMS

Please cancel Claims 17 ~~13~~ without prejudice or disclaimer of the subject matter therein.